



S O S G R O U P

**KLA Tencor  
INSPEX EAGLE**

**Patterned Wafer Laser Inspection  
sn 0201002-E25**

# KLA Tencor INSPEX EAGLE

## Patterned Wafer Laser Inspection

**Wafer Size:** 150mm capable 4" up to 8"

### Equipment Details:

Wafer inspection system

Chuck, 6"

Prealigner, 6"

Cassette to cassette handling

(2) Ports

ZEISS Microscope

Including manuals





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